



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Basol et al.  Serial No.: 10/761,877  Filed: January 21, 2004  Title: Chemical Mechanical Polishing Method And Apparatus For Controlling Material Removal Profile	Group Art Unit: 3723 Examiner: Not yet assigned Docket: NT-316-US
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**INFORMATION DISCLOSURE STATEMENT**

**US PATENT DOCUMENTS**

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant	
<i>AA</i>	AA	6,712,679	Mar., 30, 2004	Taylor et al.	Copy Enclosed

**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant		

**OTHER DOCUMENTS**

Examiner Initials	Cite No.			Trans- lation

Examiner Signature	<i>[Signature]</i>	Date Considered	<i>11/29/05</i>
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